

TITLE: LOW-RESISTANCE CONTACT TO SILICON HAVING A
TITANIUM SILICIDE INTERFACE AND AN AMORPHOUS TITANIUM
CARBONITRIDE BARRIER LAYER

Inventor: Sandhu et al.
Docket No.: 3264.5US

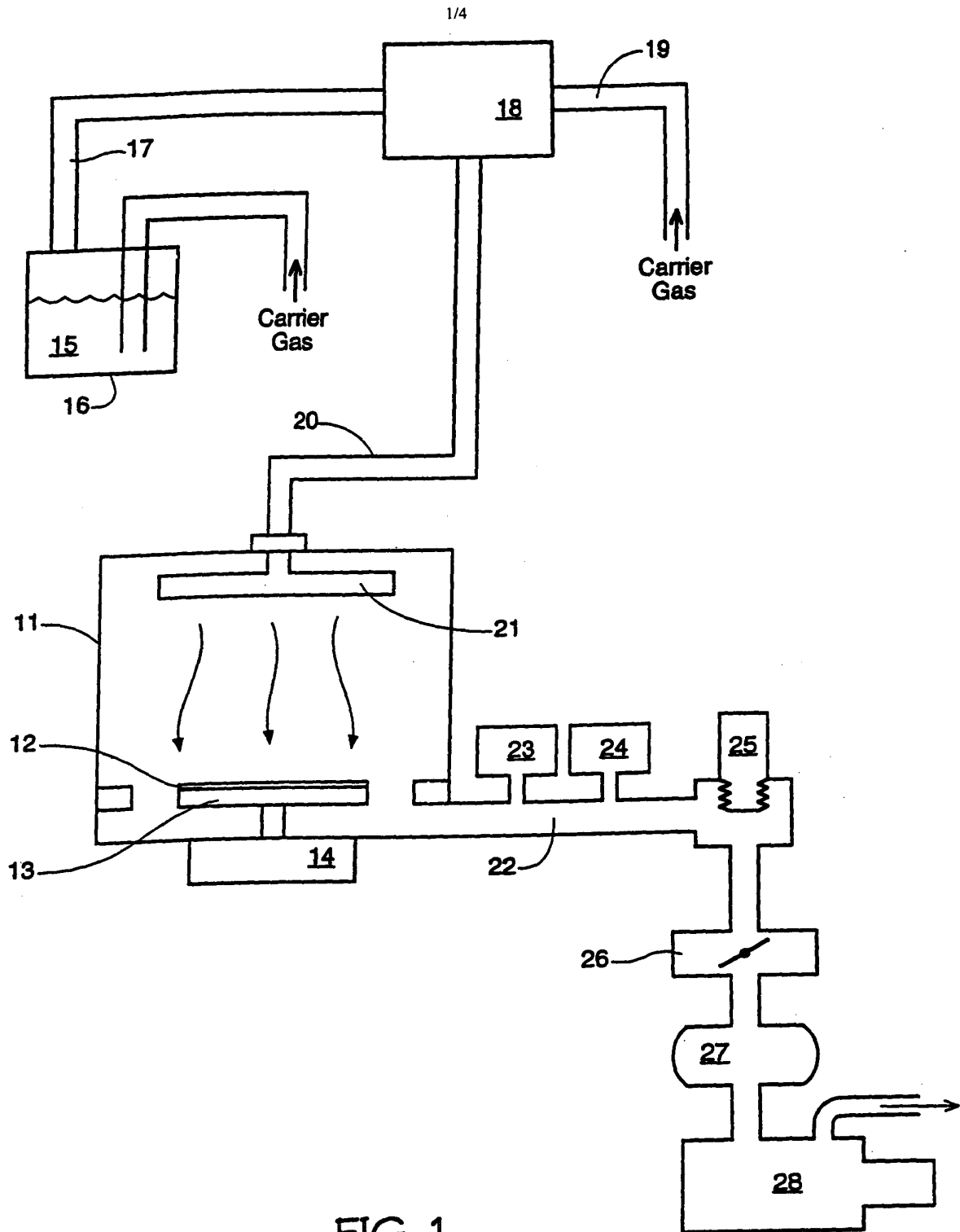


FIG. 1

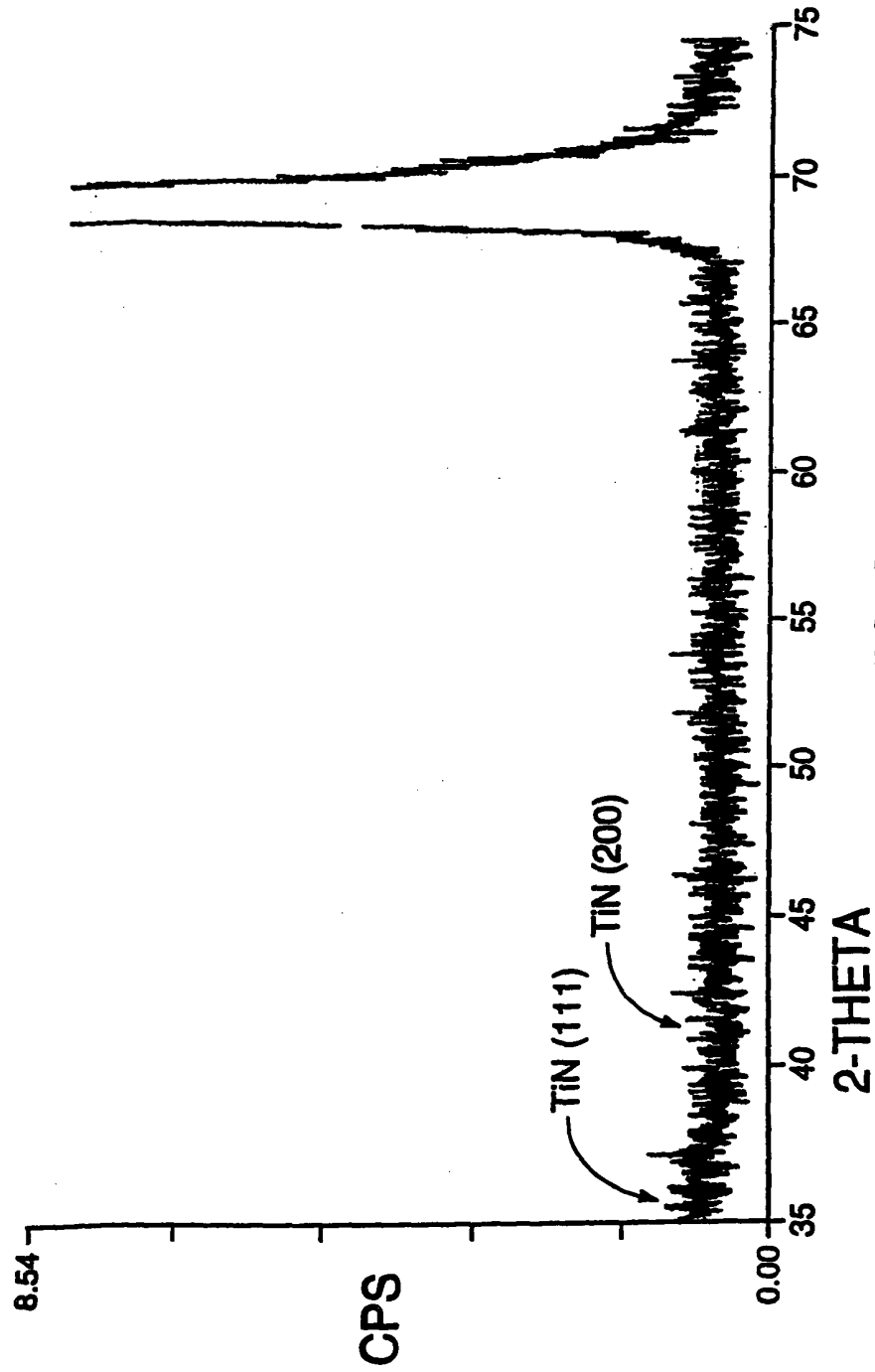


FIG. 2

